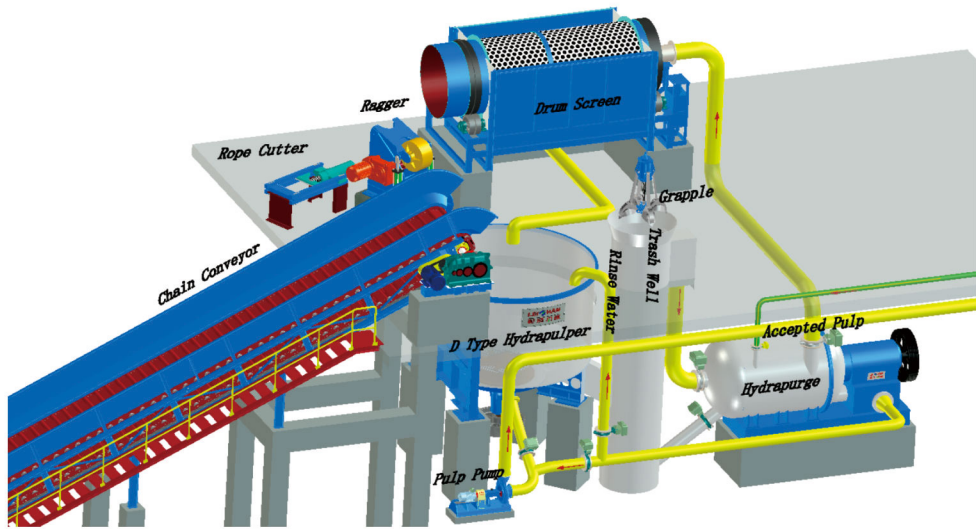


**Disposition Drawing Of Breaking In Low Consistency And Continuous Impurity-removing System**



**Disposition Drawing Of Breaking In High Consistency System**

